Docket No.: SHIGA7.036APC Customer No. 20,995

INFORMATION DISCLOSURE STATEMENT

Applicant : Masuda et al.

App. No : 10/564,510

Filed: January 12, 2006

For : POSITIVE PHOTORESIST

COMPOSITION AND METHOD OF

FORMING RESIST PATTERN

Examiner : John S Y Chu

Art Unit : 1752

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 2 references to be considered by the Examiner. Also enclosed are 2 foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing date of a Notice of Allowance.

CERTIFICATION UNDER 37 C.F.R. § 1.97(e)(1)

I hereby certify that each item of information contained in this Statement was first cited in a communication from a foreign Patent Office in a counterpart foreign application not more than 30 days prior to the filing of this Information Disclosure Statement.

Thus, no fee is required as set forth in 37 C.F.R. § 1.97(c), however, the Commissioner is

Appl. No. : 10/564,510 Filed : January 12, 2006 Docket No. SHIGA7.036APC Customer No. 20.995

hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

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3989420/mk 071007

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Multiple sheets used when necessary)
SHEET 1 OF 1

		PTO/SB/08 Equivalent
	Application No.	10/564,510
	Filing Date	January 12, 2006
	First Named Inventor	Masuda et al.
	Art Unit	1752
	Examiner	John S Y Chu
-	Attorney Docket No.	SHIGA7.036APC

U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear

	FOREIGN PATENT DOCUMENTS					
Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	τ1
	1	JP 2001075272	03-23-2001	Tokyo Ohka Kogyo Co., LTD		4

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹
	2	Office Action issued on June 12, 2007, in connection with Japanese Patent Application No. 2003- 197873.	

3989225/mk 071007

Examiner Signature Date Considered

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.